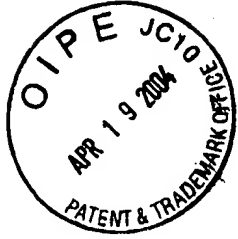


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Docket No. F-7041

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kiyohiko TAKAGI, et al.
Serial No. : 09/892,023
Filed : June 26, 2001
For : DRYING ETCHING METHOD
Group Art Unit : 2823
Examiner : William D. Coleman
Confirmation No. : 1827
Customer No. : 000028107

Certificate of Mailing Under 37 CFR 1.8

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Lawrence I. Wechsler
(Name)

Lawrence I. Wechsler
(Signature)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

04/21/2004 SDENB0B1 00000001 101250 09892023
01 FC:1252 420.00 DA

Docket No. F-7041

Ser. No. 09/892,023

INTRODUCTORY COMMENTS:

Sir:

In response to the Office Action of November 14, 2003, please amend the above-identified patent application as follows: